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Electronic Patent Application Submission
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EFS ID: 63354
Application ID: 09841800 
Title of Invention: METHOD OF DEPOSITING METAL
FILM AND METAL DEPOSITION
CLUSTER TOOL INCLUDING
SUPERCRITICAL
DRYING.CLEANING MODULE
First Named Inventor: Maximilian Biberger
Domestic/Foreign Application: Domestic Application
Filing Date: 2001-04-24
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Submission Type: Information Disclosure
Statement
Filing Type:
Confirmation number: 6810
Attorney Docket Number: NONE


Total Fees Authorized:

Digital Certificate Holder: cn=Thomas B. Haverstock,ou=Registered Attorneys,ou=Patent and
Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US
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TRANSMITTAL

Electronic Version v1.1
Stylesheet Version v1.1.0

Title of Invention	METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING.CLEANING MODULE									
Application Number: 09/841800 										
Date: 2001-04-24										
First Named Applicant: Maximilian A. Biberger										
Confirmation Number: 6810										
Attorney Docket Number:										
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<table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>Thomas B. Haverstock Registered Number: 32571</td><td>/tbh/</td><td>Attorney</td></tr></tbody></table>			Submitted by:	Elec. Sign.	Sign. Capacity	Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney		
Submitted by:	Elec. Sign.	Sign. Capacity								
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney								
<table><tr><td>Documents being submitted</td><td>Files</td></tr><tr><td>us-ids</td><td>SSI02001-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			Documents being submitted	Files	us-ids	SSI02001-usidst.xml		us-ids.dtd		us-ids.xsl
Documents being submitted	Files									
us-ids	SSI02001-usidst.xml									
	us-ids.dtd									
	us-ids.xsl									
Comments										



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of
Invention

METHOD OF DEPOSITING METAL FILM AND METAL
DEPOSITION CLUSTER TOOL INCLUDING
SUPERCRITICAL DRYING.CLEANING MODULE

Application Number: 09/841800



Confirmation Number: 6810

First Named Applicant: Maximilian Biberger

Attorney Docket Number:

Search string: (3642020 or 5091207 or 6509141 or
20030205510 or 20040020518).pn.

Certification: This Information Disclosure Statement was submitted under the following conditions, which satisfies the requirement under 37 CFR 1.97(e). The filer certified:

That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	3642020	1972-02-15	Payne			
	2	5091207	1992-02-25	Tanaka			
	3	6509141	2003-01-21	Mullee			

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass

	1	20030205510	2003-11-06	Jackson	A1
	2	20040020518	2004-02-05	DeYoung et al.	A1

Signature

Examiner Name	Date